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**CONFIRMATION NO. 4642** 

SERIAL NUMBER 09/678,266	FILING DATE 10/03/2000 RULE	CLASS 427		GROUP ART UNIT 2827		ATTORNEY DOCKET NO. 004714		
	lo Alto, CA; Alto, CA; Inion City, CA; nyvale, CA; Milpitas, CA; alo Alto, CA;	ANTED **						
12/05/2000  Foreign Priority claimed yes no Met after Allowance			ATE OR UNTRY CA				OTAL AIMS 20	INDEPENDENT CLAIMS 4
Verified and Acknowledged  Examiner's Signature Initials  ADDRESS  32588								
TITLE  METHOD AND APPARATUS FOR DEPOSITING REFRACTORY METAL LAYERS EMPLOYING SEQUENTIAL  DEPOSITION TECHNIQUES TO FORM A NUCLEATION LAYER								
FILING FEE FE	FILING FEE RECEIVED  FEES: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:				f : All Fees f : 1.16 Fees ( Filing ) f : 1.17 Fees ( Processing Ext. of time ) f : 1.18 Fees ( Issue ) f : Other			